



# UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/804,764	03/19/2004	Mark Johnsgard	PA2704US	7692
22830	7590	02/15/2008	EXAMINER	
CARR & FERRELL LLP 2200 GENG ROAD PALO ALTO, CA 94303			WU, IVES J	
ART UNIT	PAPER NUMBER	1797		
MAIL DATE	DELIVERY MODE	02/15/2008 PAPER		

**Please find below and/or attached an Office communication concerning this application or proceeding.**

The time period for reply, if any, is set in the attached communication.

<b>Office Action Summary</b>	<b>Application No.</b>	<b>Applicant(s)</b>	
	10/804,764	JOHNSGARD ET AL.	
	Examiner IVES WU	Art Unit 1797	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --  
**Period for Reply**

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If no period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED. (35 U.S.C. § 133).

Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

#### **Status**

1) Responsive to communication(s) filed on 14 January 2008.

2a) This action is FINAL.      2b) This action is non-final.

3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

#### **Disposition of Claims**

4) Claim(s) 1-27 is/are pending in the application.

4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.

5) Claim(s) \_\_\_\_\_ is/are allowed.

6) Claim(s) 1-7,15-23 and 25-27 is/are rejected.

7) Claim(s) 8-14 and 24 is/are objected to.

8) Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

#### **Application Papers**

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on \_\_\_\_\_ is/are: a) accepted or b) objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

#### **Priority under 35 U.S.C. § 119**

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).

a) All    b) Some \* c) None of:

1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

#### **Attachment(s)**

1) Notice of References Cited (PTO-892)

2) Notice of Draftsperson's Patent Drawing Review (PTO-948)

3) Information Disclosure Statement(s) (PTO/SB/08)  
Paper No(s)/Mail Date \_\_\_\_\_

4) Interview Summary (PTO-413)  
Paper No(s)/Mail Date. \_\_\_\_\_

5) Notice of Informal Patent Application

6) Other: \_\_\_\_\_

### **DETAILED ACTION**

(1). In view of Interview Summary on 12/19/2007, this is an Action of Non-final Rejection which supersedes prior Non-final Rejection dated 12/11/2007. The 3 months shortened Statutory period starts upon the mailing date of this Action.

#### ***Claim Rejections - 35 USC § 103***

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

(2). **Claims 1-7, 15-23 and 26-27** are rejected under 35 U.S.C. 103(a) as being unpatentable over Johnsgard (US04986838) in view of Han (US06090208A) for the same rationale recited in prior Office Action dated 07/12/2007.

As to a scrubber interface device in fluid communication with the inlet manifold and configured to deliver the effluent gas stream from the inlet manifold to a gas scrubbing system a scrubber inlet device in independent claim 1, Johnsgard (US04986838) discloses an inlet system for scrubber (Title). An effluent gas scrubbing system is disclosed having improved scrubber inlet system including a transition tube having a fluted lower portion for directing particulate carrying, gas into the mist saturated scrubbing chamber of a gas scrubber (Abstract, line 1-5). As shown in Figure 2 below, the scrubber inlet system 14 is in fluid communication with inlet pipe 18, and deliver the effluent gas stream from inlet 18 to a gas scrubbing system 12. As to a port configured to receive an effluent gas stream from an exhaust line in inlet manifold in independent claim 1, Johnsgard discloses gas entry 16 with inlet pipe 18 as shown in Figure 2 .

As to a heated gas inlet configured to received a stream of heated gas in an inlet manifold in independent claim 1, Johnsgard does not teach such manifold including a heated gas inlet as claimed. However, Han (US06090208A) teaches prevention of clogging in CVD apparatus (Title). As shown in the Figure 3 below, a hot gas inlet 34 in approximate to the outlet port of vacuum pump 11. The advantage of injecting a hot gas into the apparatus is to maintain the temperature of internal walls of the apparatus above the temperature at which condensation of the vapor occurs (Col. 3, line 32-35). Therefore, it would have been obvious at time of the invention to install a hot gas inlet disclosed by Hart near the gas entry 16 in the gas scrubber inlet

system of Johnsgard in order to obtain the above-cited advantage. As to port including an insulating insert sleeve in claim 2, insulation around an exterior in claim 3, it would be obvious to one of ordinary skills in the art to further prevent from the clogging of gas effluent by additional preventive means such as insulating insert sleeve and insulation around exterior to keep the gas effluent from cooling in the apparatus.

As to scrubber interface device including a lower portion having a generally cylindrical interior surface in claim 4, Johnsgard discloses scrubber inlet system 14 including a transition tube 24 in Figure 2 above. As to an insulated insert portion providing fluid communication between the inlet manifold and the lower portion of the scrubber interface device in claim 4, Johnsgard does not disclose the insulated insert portion. However, it would have been obvious to one of ordinary skills in the art to use insulated insert portion as means to keep the gas effluent from clogging due to the heat loss anywhere in the lower portion of cylindrical interior surface. As to scrubber interface device further including a system for providing a washing fluid to the cylindrical interior surface of the lower portion in claim 5, Johnsgard discloses the transition gas 33 to be formed so that as fluid 35 exiting the cavity 34, it maintains a high rotational velocity as it travels down the length of the transition tube 24 in the Figure 2 above. As to insulated portion extending into the inlet manifold in claim 6, Johnsgard does not disclose the insulated insert portion extending to the inlet area, however, it would have been obvious to one of ordinary skills in the art at time of the invention to extend the insulated insert portion into the inlet area to provide maximum heat insulation to prevent from clogging by the condensation of gas effluent. As to inlet manifold to be separable from scrubber interface device in claim 7, Johnsgard discloses the inlet of gas entry 16 being glued to a 1st threaded union 17a, which is in turn threadably engaged to the union nut 17b. Union nut 17b is then threadably engaged to a 2nd thread union 17c, which is glued to inlet pipe 18 (Col. 4, line 39-43). Inlet pipe 18 maybe readily removed by unthreading the union nut 17b from supply pipe 16 and removing the inlet pipe 18 (Col. 6, line 1-4). As to source of heated gas configured to provide the stream of heated gas to the heated gas inlet in claim 15, Han (US06090208) discloses source of gas 33 in the Figure 3 above. As to heated gas providing an inert gas in claim 16, inert gas to be N2 in claim 17, Han discloses, in an embodiment, the gas source comprises a source of dried air, nitrogen or an inert gas, preferably dried air or nitrogen (Col. 4, line 63-65). As to the temperature regulation system

for the hot gas in claim 18, temperature sensor, controller to regulate the temperature of heated gas according to a signal from the sensor in claim 19, Han discloses the temperature of hot gas at temperature of about 20 °C to about 260 °C, preferably 40 °C to about 90 °C (Col. 6, line 7-8). Therefore, it would have been obvious to have temperature regulation system to control the temperature ranged from 40 °C to 90 °C preferably, in order to effectively prevent or substantially reduce the condensation in the gas effluent. It would be obvious also to one of ordinary skills in the art to have temperature sensor and controller in temperature regulation in order to regulate the temperature of the hot gas because it is well known in the art that the controlling function requires an input of controlled parameter from measuring device such as sensor and controlling device such as controller. As to step of receiving effluent gas stream into manifold in a method for delivering an effluent gas stream into a gas scrubbing system in independent claim 20, Johnsgard discloses inlet pipe 18 to receive the effluent gas in Figure 2 above. As to step of heating interior surface of the manifold to near a condensation temperature of the effluent gas in a method in independent claim 20, Johnsgard (US04986838) does not teach step of heating the surface of the manifold as claimed. However, Han (US06090208) teaches the hot gas to be capable of maintaining the internal walls of effluent line below the condensation temperature of the condensable gaseous species (Col. 5, line 49-52). The advantage of heating the surface of effluent line is to prevent the condensation of condensable effluent gas, which causes plugging problem (Col. 4, line 58-62). Therefore, it would have been obvious at time of the invention to include step of heating the internal surface of manifold disclosed by Han in the gas scrubber inlet system of Johnsgard in order to obtain the above-cited advantage. As to step of providing effluent gas stream to an interface device that is effective to suppress nucleation of condensation from effluent gas stream, and configured to direct effluent gas stream into gas scrubbing system in independent claim 20, Johnsgard discloses the inlet system for gas scrubber including the inlet system 14 as shown in Figure 2 above. BY swirling or spinning the fluid in the transition tube, the internal walls of the transition tube may be completely coated with a washing flow of fluid and continuously flushed so as to prevent SiO<sub>2</sub> buildup (Col. 5, line 15-19). The interface opening 40 allows gas to pass from the transition tube to the initial scrubbing chamber without creating unflushed surfaces in the transition tube or the scrubbing chamber (Col. 6, line 27-32). As to condensation temperature of aluminum chloride in claim 21, Han

Art Unit: 1797

discloses temperature of condensable species, such as WOF4 (Col. 5, line 49-52). It would have been obvious to have condensable temperature for aluminum chloride once the effluent is for aluminum chloride. As to heating interior surfaces of manifold including flowing a heated gas stream into the manifold in claim 22, Han discloses the flowing of heated gas into effluent gas as shown in Figure 3 above. As to pass the effluent gas stream through an abrupt hot-to-cold transition region in order to suppress condensation in claim 23, Johnsgard discloses the transition tube 24, the abrupt dry- to-wet transition minimizing the formation of stagnant wet surfaces on which SiO<sub>2</sub> may collect and the smoothness of that transition reduces the extent of gas turbulence, which can cause fluid mist to be carried back into the dry inlet pipe 18. The dry pipe includes the hot gas heating and inlet system includes spray of water, dry-to-wet transition reads on hot-to-cold transition on instant claim. As to inlet manifold including a port configured to receive an effluent gas stream from exhaust line and a scrubber interface device in fluid communication with the inlet manifold to a gas scrubbing system in a scrubber inlet device in independent claim 26, the disclosure of Johnsgard, Han is incorporated herein by reference, the most subject matters as claimed, have been recited in applicants' claim 1 and have been discussed therein. As to the effluent gas stream at a 1st temperature and means for maintaining the effluent gas stream at or near the 1st temperature in independent claim 26, the disclosure Han is incorporated herein by reference, the most subject matters as currently claimed has been recited in applicants claims 1 and 20 and have been discussed therein. As to the insulated insert portion in scrubber inlet device in claim 27, the disclosure of Johnsgard, Han is incorporated herein by reference, the most subject matter as currently claimed, has been recited in applicants' claim 4, and has been discussed therein.

(3). **Claim 25** is rejected under 35 U.S.C. 103(a) as being unpatentable over Johnsgard (US04986838) in view of Han (US06090208A), further in view of Lane et al (US05846275).

As to step of clearing the interface device in **claim 25**, Johnsgard, Han **do not teach** clearing as claimed.

However, Lane et al (US05846275A) **teach** plunger mechanisms or other solids removal means for inlet clogging problem (Col. 1, line 53-53).

The advantage of use cleaning out clogging is routine engineering maintenance work.

Therefore, it would have been obvious at time of the invention to clean the clogging problem disclosed by Lane et al in the inlet system of Johnsgard in order to obtain the above-cited advantage.

*Allowable Subject Matter*

(4). **Claims 8-14 and 24** are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

*Response to Arguments*

Applicant's arguments, see interview summary, filed 12/28/07, with respect to claims 8-14 and 25 have been fully considered and are persuasive. The rejection of 12/11/2007 has been withdrawn. Applicant's arguments filed on 10/15/2007 have been fully considered but they are not persuasive. Applicants address that the prior art Johnsgard (US04986838) does not disclose a inlet manifold, only teaches an inlet pipe 18, not equate with the inlet manifold of instant claim 1 (page 8-9, Remarks of 10/15/2007). Although it is recognized that Johnsgard (US04986838) does not teach an inlet manifold, however, when the inlet pipe including a hot gas input will form a Johnsgard's (US04986838) manifold. One can not show nonobviousness by attacking references individually where the rejections are based on combinations of references. In re Keller, 642 F.2d 413, 208 USPQ 871 (CCPA 1981); In re Merck & Co., 800 F.2d 1091, 231 USPQ 375 (Fed. Cir. 1986).

*Conclusion*

Any inquiry concerning this communication or earlier communications from the examiner should be directed to IVES WU whose telephone number is (571)272-4245. The examiner can normally be reached on 8:00 - 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Duane Smith can be reached on 571-272-1166. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Art Unit: 1797

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Examiner: Ives Wu

Art Unit: 1797

Date: February 8, 2008

/Duane S. Smith/

Supervisory Patent Examiner

Art Unit 1797

2-13-08